



#13 / *examining charges*  
Docket No. 8733.378.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re application of

Myoung Su YANG

Serial No.: 09/748,871

Filed: December 28, 2000

For: Method of Forming A Polycrystalline Silicon Layer

Group Art Unit: 2812

Examiner: Pompey, R.

1/14/03  
RECEIVED  
JAN - 8 2003  
TECHNOLOGY CENTER 2800

TRANSMITTAL OF DRAWING CORRECTIONS

Box Non-Fee Amendment

Assistant Commissioner of Patents

Washington, D.C. 20231

Sir:

Applicants submit proposed drawing corrections as shown in red in the appended informal drawings. The following changes are proposed:

Replace the designation "Figure 1B" with --Figure 1C--;

Insert new Figure 1B and accompanying drawing;

Move Figure 2 and accompanying drawing to new page.

REMARKS

No new matter has been added. Favorable consideration is sought therefore.

Applicants' undersigned attorney may be reached in our Washington office by telephone at (202) 496-7500. All correspondence should be directed to the below-listed address.

Applicants hereby authorize the Commissioner of Patents to charge any fees necessary to complete this filing, including any fees required under 37 C.F.R. §1.136 for any necessary Extension of Time to make the filing of the attached documents timely, or credit any overpayment in fees, to Deposit Account No. 50-0911. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. §1.136 for the necessary extension of time. A copy of this sheet is enclosed.

Respectfully submitted,  
MCKENNA LONG & ALDRIDGE LLP

Date: January 6, 2003

By: *Teresa M. Arroyo*  
Teresa M. Arroyo  
Registration No: 50,015

1900 K Street, N.W.  
Washington, D.C. 20006



30827

PATENT TRADEMARK OFFICE

DC:116226.1